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*Counsel for Defendants Roger Jinteh Arrigo Chen and  
Genia Technologies, Inc.*

**UNITED STATES DISTRICT COURT  
NORTHERN DISTRICT OF CALIFORNIA  
SAN FRANCISCO DIVISION**

THE REGENTS OF THE UNIVERSITY OF  
CALIFORNIA, a California corporation,

Plaintiff,

v.

ROGER JINTEH ARRIGO CHEN, an individual;  
GENIA TECHNOLOGIES, INC., a Delaware  
corporation; and DOES 1-25,

Defendants.

Case No. 3:16-cv-07396-WHO

**DECLARATION OF ROBERT J.  
GUNTHER, JR., IN SUPPORT OF  
DEFENDANTS' MOTION TO  
DISMISS COMPLAINT**

Presiding: Hon. William H. Orrick

Date: April 26, 2017

Time: 2:00 PM

Courtroom: Courtroom 2, 17<sup>th</sup> Floor

**DECLARATION**

I, Robert J. Gunther, Jr., declare as follows:

1. I am an attorney licensed to practice in the State of New York and a partner in the law firm of Wilmer Cutler Pickering Hale and Dorr LLP, representing Defendants Roger Jinteh Arrigo Chen and Genia Technologies, Inc. (collectively, “Defendants”), in the above-captioned matter. I am admitted to this Court under Civil L.R. 11-1(b) as an attorney admitted before September 1, 1995, based on membership in the bar of a jurisdiction other than California (i.e., New York) and continuing active membership in the bar of that jurisdiction.
2. I submit this Declaration in support of Defendants’ Motion to Dismiss Plaintiff’s Complaint.
3. Attached hereto as Exhibit A is a true and correct copy of U.S. Patent No. 8,324,914.
4. Attached hereto as Exhibit B is a true and correct copy of U.S. Patent No. 8,461,854.
5. Attached hereto as Exhibit C is a true and correct copy of U.S. Patent No. 9,041,420.
6. Attached hereto as Exhibit D is a true and correct copy of U.S. Patent No. 9,377,437.
7. Attached hereto as Exhibit E is a true and correct copy of U.S. Patent Application No. 15/079,322.
8. Attached hereto as Exhibit F is a true and correct copy of Bibliographic Data for Application Number 60/921,787, retrieved from the Patent Application Information Retrieval portal (<http://portal.uspto.gov/pair/PublicPair>) on February 22, 2017.
9. Attached hereto as Exhibit G is a true and correct copy of Bibliographic Data for Application Number 60/931,115, retrieved from the Patent Application Information Retrieval portal (<http://portal.uspto.gov/pair/PublicPair>) on February 22, 2017.

1 10. Attached hereto as Exhibit H is a true correct copy of Bibliographic Data for  
2 Application Number 60/967,539, retrieved from the Patent Application Information  
3 Retrieval portal (<http://portal.uspto.gov/pair/PublicPair>) on February 22, 2017.

4 11. Attached hereto as Exhibit I is a true and correct copy of Bibliographic Data for  
5 Application Number 12/080,684, retrieved from the Patent Application Information  
6 Retrieval portal (<http://portal.uspto.gov/pair/PublicPair>) on February 22, 2017.

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8 I declare under the pains and penalty of perjury under the laws of the United States that  
9 the foregoing is true and correct to the best of my knowledge.  
10

11 Dated: February 27, 2017.

**WILMER CUTLER PICKERING  
HALE AND DORR LLP**

13  
14 /s/ Robert J. Gunther, Jr.

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22 *Counsel for Defendants Roger Jinteh Arrigo*  
23 *Chen and Genia Technologies, Inc*  
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**CERTIFICATE OF SERVICE**

The undersigned hereby certifies that a true and correct copy of the above and foregoing document has been served on February 27, 2017, to all counsel of record who are deemed to have consented to electronic service via the Court's CM/ECF system per Civil Local Rule 5.5. Any other counsel of record will be served by electronic mail, facsimile, and/or overnight delivery.

/s/ Robert J. Gunther, Jr.